

**Certificate of Mailing under 37 CFR 1.8**Applicant(s): **Kamiya et al.**

Docket no. 90736

| Application No. | Filing Date: | Examiner: | Customer No. | Group Art Unit: |
|-----------------|-----------------|-----------|--------------|-----------------|
| 10/679,031 | October 3, 2003 | Song | 24628 | 1722 |

Invention: Silicon Wafer and Method for Manufacturing Thereof, and Method of Evaluation of Silicon Wafer

I hereby certify that this Request for Continued Examination and Amendment is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on January 11, 2007

(Date)

Gerald T. Shekleton Reg. No. 27,466
(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing, or this certificate must identify each submitted paper.

Request for Continued Examination, Combined Amendment Transmittal letter with Certificate of Mailing by First Class Mail (37 CFR 1.8) and Petition for 3 Month Extension of Time with fee, Amendment; 2 checks in the amounts of \$790.00 and \$1020.00, and Postcard.

The Commissioner is hereby authorized to charge any fees which may be required, including, if necessary, the filing fee if the above-referenced check is in the wrong amount, unsigned, postdated, or otherwise improper or informal or missing, or credit any overpayment to Deposit Account No. 23-0920.